

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination	
	10/706,238	KAN, MAKIKO	
Examiner	Sun J. Lin	Art Unit	2825

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
716	1	2/16/2006	JSL
716	2	2/16/2006	JSL